## a 2020 0038

The invention relates to a technology for producing nanostructured materials, in particular to a technology for producing a network of CuO-Fe<sub>2</sub>O<sub>3</sub> nanowires by thermal oxidation in the environment, which can be used in the manufacture of gas sensors and various micro-optoelectronic devices.

The process, according to the invention, includes degreasing of the glass, application on the surface of iron microparticles (size  $50...60 \mu m$ ) and copper microparticles (size  $15...25 \mu m$ ), thermal oxidation in air at a temperature of  $425^{\circ}C$  for 4 hours with the rate of temperature rise in the furnace of  $40^{\circ}C/min$ .

Claims: 1 Fig.: 4